

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

11-15-01

Group Art Unit:

~~Unknown~~ 1746 Ahmed

Inventor:

Chang, et al

Serial No.

~~To Be Assigned~~ 09/818313

Filed:

~~Herewith~~ 3.2701

jc997 U.S. PTO

09/818313

For: Method And System For Efficiently Scheduling  
Multi-Chamber Fabrication Tool Capacity

Attorney Docket No.: 67,200-392

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:  
Assistant Commissioner for Patents, Washington, D.C. 20231.

Date: March 27, 2001

Kathy Dixon

DISCLOSURE STATEMENT  
UNDER 37 C.F.R. § 1.56

Assistant Commissioner  
for Patents  
Washington, D.C. 20231

Sir:

In compliance with 37 C.F.R. § 1.56, the art listed and identified on the attached Form PTO-1449 is being submitted herewith for consideration by the Examiner. A copy of each of the listed references is included herewith.

It is Applicant's opinion that the claims presently on file patentably distinguish the present invention from each of these references. The above references are being cited only in the interests of candor and without any admission that they constitute

statutory prior art or contain matter which anticipates the invention or which would render the same obvious, either singly or in combination, to a person of ordinary skill in the art.

Respectfully submitted,

TUNG & ASSOCIATES

By  \_\_\_\_\_

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Dated: March 27, 2001

<b>FORM PTO-1449 (MODIFIED)</b>  LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT  (Use several sheets if necessary)	ATTY DOCKET NO.	SERIAL NO.
	67,200-392	Filed Herewith
	APPLICANT Chang, et al	
	FILING DATE	GROUP
	Filed Herewith	Unknown

JCD997 U.S. PTO  
 09/818313  
 03/27/01

**REFERENCE DESIGNATION U.S. PATENT DOCUMENTS**

EXAMINER INITIAL		DOCUMENT NO.	DATE	NAME	CLASS	SUB CLASS	FILING DATE
	AA	6,074,443	06/2000	Venkatesh et al			
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						

**FOREIGN PATENT DOCUMENTS**

EXAMINER INITIAL		DOCUMENT NO.	DATE	COUNTRY	CLAS S	SUB CLASS	TRANSLATION YES/NO
	AK						
	AL						
	AM						
	AN						

**OTHER ART (including Author, Title, Date, pertinent pages, etc.)**

	AO	
	AP	

EXAMINER \_\_\_\_\_ DATE CONSIDERED \_\_\_\_\_

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to application.